



UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) Martin Peiter et al. GROUP ART UNIT: 1746
APPLN. NO.: 10/016,633 EXAMINER:
FILED: October 30, 2001
TITLE: WAFER SCRIBING METHOD AND WAFER SCRIBING DEVICE

Certificate of MailingDate of deposit: 2/22/02

I hereby certify that this paper is being deposited with the United States Postal Service on the date indicated above, as first-class mail, with sufficient postage attached thereto, in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C.

Signature of Person Mailing PaperElaine Cox_____
Printed Name of Person Mailing PaperPRELIMINARY AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Please enter this Preliminary Amendment in the above-entitled application.